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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

		D THEIDENHALL OFFICE
In re Patent Hiroki Ose	Application of: et al.	-
Application	No.: Not Yet Assigned	Confirmation No.: N/A
Filed: Concu	urrently Herewith	Art Unit: N/A
	EANING APPARATUS, CLEANING TEM AND CLEANING METHOD	Examiner: Not Yet Assigned
	INFORMATION DISCLOSURE	STATEMENT (IDS)
P.O. Box 14	er for Patents 50 VA 22313-1450	
Dear Sir:	•	
to Applicant Applicant re formally be r	Submitted herewith on Form PTO-1449 or P' in order to comply with Applicant's duty of a specifully requests that the listed document made of record in the present application an VSB/08 be returned in accordance with MP	disclosure pursuant to 37 CFR 1.56. s be considered by the Examiner and that an initialed copy of Form PTO-
	As provided in 37 CFR §1.98(d), copies since they were previously cited by or su application Serial No, file	bmitted to the Patent Office in parent
	A copy of each listed document, that was a International Preliminary Examination Reprovided to the U.S. Patent and Trademan of 37 CFR §§1.97 and 1.98 should have be	port attached hereto, should have been of Office by the WIPO, and the provisions

10/554265

Docket No.: ISH-0237

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- This Information Disclosure Statement is being filed within three months of the U.S. filing date or within three months from the date of entry of the national stage as setforth in 37 C.F.R. §1.491 in compliance with 37 C.F.R. §1.97(b), OR is being filed concurrent with filing of the Continued Prosecution Application (CPA) or the Request for Continued Examination (RCE). No fee is required (37 C.F.R. §1.97(b)).
- 2. Please charge any fee deficiency or credit any overpayment to Deposit Account No. 18-0013 as needed to ensure consideration of the disclosed information.

Dated: October 25, 2005

Respectfully submitted,

David T. Nikaido

Registration No.: 22,663 RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W.

Res #40949

Suite 501 Washington, DC 20036

(202) 955-3750 Attorney for Applicant

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				Application Number	Not Assigned 4 265	
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				Art Unit	N/A	
(Use as many sheets as necessary)			necessary)	Examiner Name	Not Yet Assigned	
Sheet	1	of	1	Attomey Docket Number	ISH-0237	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

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